



Sheet 1 of 1

Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 27391/US588	Serial No. 10/617,560
INFORMATION DISCLOSURE STATEMENT		Applicant Nakayama	
		Filing Date 7/11/03	Group

U.S. PATENT DOCUMENTS							
*Examiner Initials	Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate	
RST	5,175,658	12/29/92	Chang et al.	360	103		

FOREIGN PATENT DOCUMENTS								
*Examiner Initials	Document Number	Publication Date	Country	Class	Subclass	Translation		
						Yes	No	
RST	59174508 A	10/03/84	Japan			Abstract only		
	62145646 A	06/29/87	Japan			Abstract only		
	62145647 A	06/29/87	Japan			Abstract only		
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	10275308 A	10/13/98	Japan			Abstract only		
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)	
RST	New Diamond, Japan New Diamond Forum 11, October 1988, Vol. 4, No. 4, pp. 14-17
RST	"Bias Effect on the Formulation of Carbon Films by RF-Plasma CVD", Nakayama et al., Journal of Ceramic Society of Japan Int. Edition, Vol. 98, 1990, pp. 597-600

Examiner R.S. Truman	Date Considered 9/05
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